

L Number	Hits	Search Text	DB	Time stamp
1	66	205/96.ccls. and semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/09/21 14:15
-	80	204/230.7.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/08/26 18:24
-	5	204/230.7.ccls. and semiconductor NEAR wafer	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/08/26 18:25